

**Growth dynamics of nanocrystalline diamond films produced by microwave plasma enhanced chemical vapor deposition in methane/hydrogen/air mixture : scaling analysis of surface morphology**

**Podgurski, Vitali; Bogatov, Andrei; Sedov, V.; Sildos, Ilmo; Mere, Arvo; Viljus, Mart;** Buijnsters, J. G.; Ralchenko, V. *Diamond and related materials* 2015 / p. 172-179 : ill <http://dx.doi.org/10.1016/j.diamond.2015.07.002>

**Thermal annealing of sequentially deposited SnS thin films**

**Safonova, Maria;** Nair, Padmanabhan Pankajakshy Karunakaran; **Melikov, Enn;** Aragon, Rebeca; **Kerm, Karin; Naidu, Revathi; Mikli, Valdek; Volobujeva, Olga** *Proceedings of the Estonian Academy of Sciences* 2015 / p. 488-494 : ill <http://dx.doi.org/10.3176/proc.2015.4.04>